



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/532,991 Confirmation No. : 2959  
First Named Inventor : Mitsuhiro YUASA  
Filed : April 28, 2005  
TC/A.U. : 2812  
Examiner : A. Roman  
  
Docket No. : 101249.56268US  
Customer No. : 23911  
  
Title : Process Monitor and System for Producing Semiconductor

**REPLY**

**Mail Stop RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the Final Office Action dated November 9, 2006, the period for response having been extended to April 9, 2007 by the attached Petition for Extension of Time.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. *Additional claims fees are submitted herewith.*

**Remarks** begin on page 7 of this paper.

03/29/2007 MKAYPAGH 00000048 10532991

01 FC:1615 150.00 OP  
02 FC:1614 400.00 OP